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Notice of Allowability	Application No.	Applicant(s)	
	10/767,786	OHTO ET AL.	
	Examiner	Art Unit	
	Ori Nadav	2811	
The MAILING DATE of this communication appear All claims being allowable, PROSECUTION ON THE MERITS IS (herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIC of the Office or upon petition by the applicant. See 37 CFR 1.313	OR REMAINS) CLOSED in this apport of the appropriate communication  SHTS. This application is subject to	olication. If not included will be mailed in due course. THIS	
1.  This communication is responsive to <u>amedment filed on 5/8</u>	<u>/2006</u> .		
2. X The allowed claim(s) is/are <u>1-26 and 83-89.</u>			
<ul> <li>3.  Acknowledgment is made of a claim for foreign priority undanisms.</li> <li>a)  All b)  Some* c)  None of the: <ol> <li>Certified copies of the priority documents have</li> <li>Certified copies of the priority documents have</li> <li>Copies of the certified copies of the priority documents have International Bureau (PCT Rule 17.2(a)).</li> </ol> </li> <li>* Certified copies not received:</li> </ul> Applicant has THREE MONTHS FROM THE "MAILING DATE" of the priority documents have an experiment of the priority documents have a priority document of the priority documen	been received.  been received in Application No  uments have been received in this r  f this communication to file a reply o	national stage application from the	
noted below. Failure to timely comply will result in ABANDONME THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.  4. A SUBSTITUTE OATH OR DECLARATION must be submitted.	ted. Note the attached EXAMINER's	S AMENDMENT or NOTICE OF	
INFORMAL PATENT APPLICATION (PTO-152) which gives	reason(s) why the oath or declarat	ion is deficient.	
<ol> <li>CORRECTED DRAWINGS (as "replacement sheets") must</li> <li>(a) including changes required by the Notice of Draftsperso</li> <li>1) hereto or 2) to Paper No./Mail Date</li> <li>(b) including changes required by the attached Examiner's Paper No./Mail Date</li> </ol>	n's Patent Drawing Review ( PTO-9		
Identifying indicia such as the application number (see 37 CFR 1.8 each sheet. Replacement sheet(s) should be labeled as such in the	4(c)) should be written on the drawing header according to 37 CFR 1.121(d	gs in the front (not the back) of 1.	
<ol> <li>DEPOSIT OF and/or INFORMATION about the deposition attached Examiner's comment regarding REQUIREMENT For attached Examiner Ex</li></ol>	t of BIOLOGICAL MATERIAL m	ust be submitted. Note the	
		,	
Attachment(s) 1. □ Notice of References Cited (PTO-892)	5   Notice of Informal Pa	tent Application (PTO-152)	
2. Notice of Draftperson's Patent Drawing Review (PTO-948)	6. ☐ Interview Summary (	• • • • • •	
Information Disclosure Statements (PTO-1449 or PTO/SB/08)     Paper No./Mail Date	Paper No./Mail Date	),	
<ol> <li>Examiner's Comment Regarding Requirement for Deposit of Biological Material</li> </ol>	8. ⊠ Examiner's Statemer 9. □ Other	8. ☑ Examiner's Statement of Reasons for Allowance  9. ☐ Other	
		ORI NADAV PRIMARY EXAMINER	

## **DETAILED ACTION**

## Examiner's Amendment

This application is in condition for allowance except for the presence of claims 27-38 directed to a non-elected embodiment without traverse. Accordingly, claims 27-38 have been cancelled.

Please change the title from "semiconductor device, and production method for manufacturing such semiconductor device" to "semiconductor device having two distinct SiOCH layers". A new title was required, because the title of the invention was not clearly indicative of the invention to which the claims are directed.

## Reasons for allowance

The following is an examiner's statement of reasons for allowance: The prior art of record does not teach or suggest, singularly or in combination, at least the limitations of a semiconductor device having a second SiOCH layer of a hydrogen density that is lower than that of a first SiOCH layer.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

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Any inquiry concerning this communication or earlier communications from the

examiner should be directed to Ori Nadav whose telephone number is 571-272-1660.

The examiner can normally be reached between the hours of 7 AM to 4 PM (Eastern

Standard Time) Monday through Friday.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's

supervisor, Eddie Lee can be reached on 571-272-1732. The fax phone number for the

organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the

Patent Application Information Retrieval (PAIR) system. Status information for

published applications may be obtained from either Private PAIR or Public PAIR.

Status information for unpublished applications is available through Private PAIR only.

For more information about the PAIR system, see http://pair-direct.uspto.gov. Should

you have questions on access to the Private PAIR system, contact the Electronic

Business Center (EBC) at 866-217-9197 (toll-free).

O.N. 7/4/06 ORI NADAV
PRIMARY EXAMINER
TECHNOLOGY CENTER 2800

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